

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Chapple-Sokol *et al.* Examiner: Kebede, Brook

Serial No.: 10/708,486 Group Art Unit: 2823

Filed: 03/06/2004

**Title: SUPPRESSION OF LOCALIZED METAL PRECIPITATE FORMATION  
AND CORRESPONDING METALLIZATION DEPLETION IN  
SEMICONDUCTOR PROCESSING**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**OFFICE ACTION RESPONSE**

Sir:

This response is in response to the Final Office Action mailed August 24, 2006.